
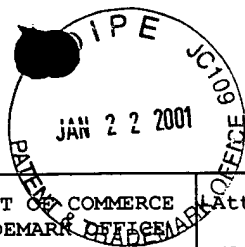


Form PTO-1449 (REV. 7-80)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		Atty. Docket No. NL 000172		Serial No.	
INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)				Applicant GERARDUS P.M. EGELMEERS ET AL.		<div style="text-align: right;">  </div>	
				Filing Date CONCURRENTLY			
U.S. PATENT DOCUMENTS							
Ex. Int.	Document Number	Date	Name	Class	Sub-class	Filing Date If Approp.	
AA	5 8 2 8 7 5 6	10/27/88	BENESTY ET AL.	381	66	11/12/96	
AB	4 9 0 3 2 4 7	2/20/90	VAN GERWEN ET AL.	367	435		
AC							
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AG	W 0 9 7 4 5 9 9 5	12/4/97	INTERNATIONAL (PCT)	H04M	9/08	X	
AH							
AI							
AJ							
AK							
OTHER (Including Author, Title, Date, Pertinent Pages, Etc.)							
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Examiner <i>Pf</i>				Date Considered 6/25/04			
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(REV. 7-80) PATENT AND TRADEMARK OFFICE

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Applicant

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	Document Number	Date	Country	Class	Sub- clas s	Trans.	
						Yes	No
	AG						
	AH						
	AI						
	AJ						
	AK						

OTHER (Including Author, Title, Date, Pertinent Pages, Etc.)

AL	"Real Time Realization Concepts of large Adaptive filters" Ph.D. G.P.M. Egelmeers, thesis, Eindhoven University of Technology, Eindhoven (The Netherlands), Nov. 1995.
AM	
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Examiner

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